

Emittance Measurement Speedup with Machine Learning at Coherent electron Cooling experiment at RHIC†

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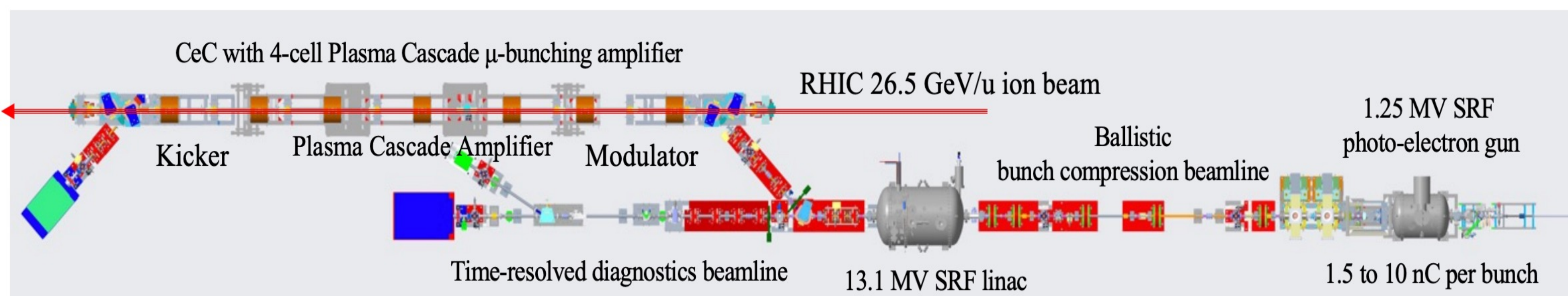
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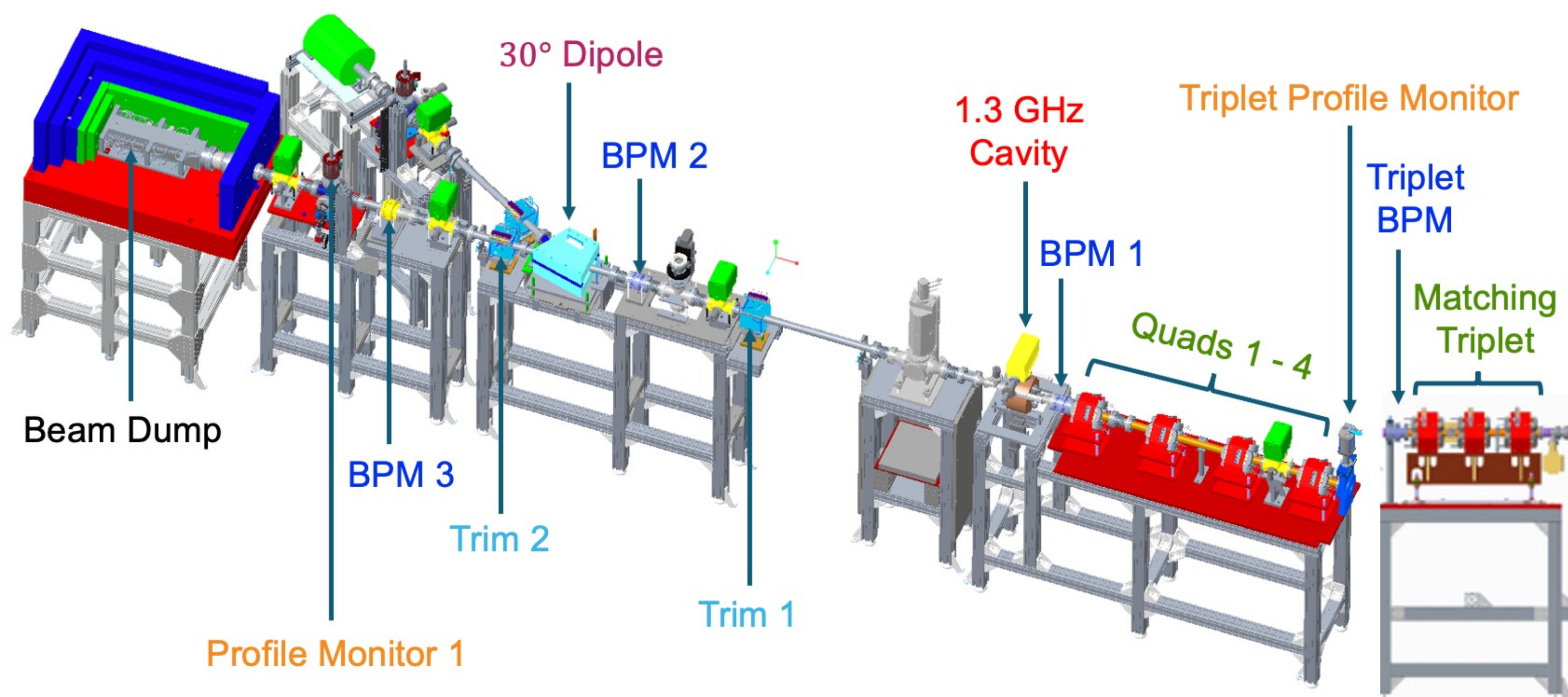
Coherent electron Cooling (CeC)



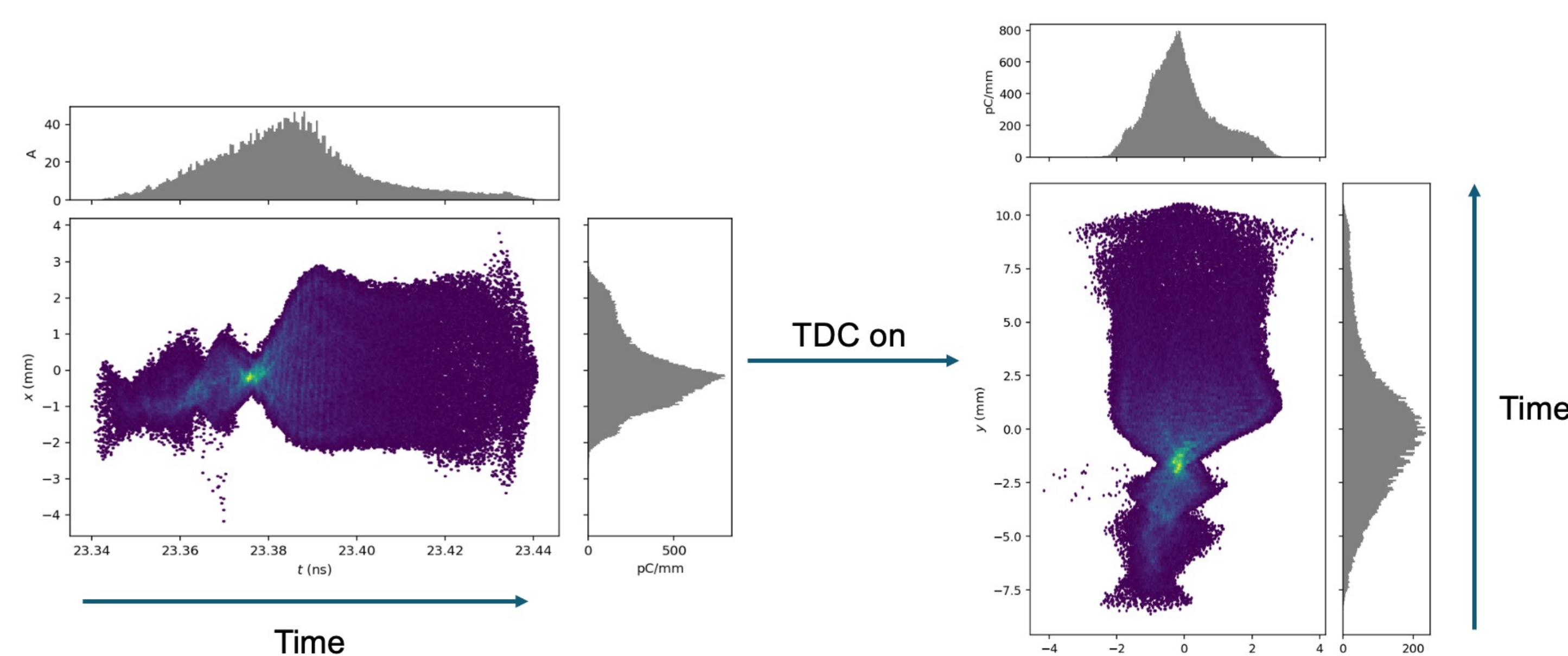
- Coherent electron cooling promises fast cooling of high energy hadrons
- Three main components of CeC system:
 - **Modulator** – hadrons imprint density wakes on electrons
 - **Amplifier** – amplifies density imprints
 - **Kicker** – hadrons interact with modulated electrons

Time-resolved Diagnostic Beamline (TRDBL)

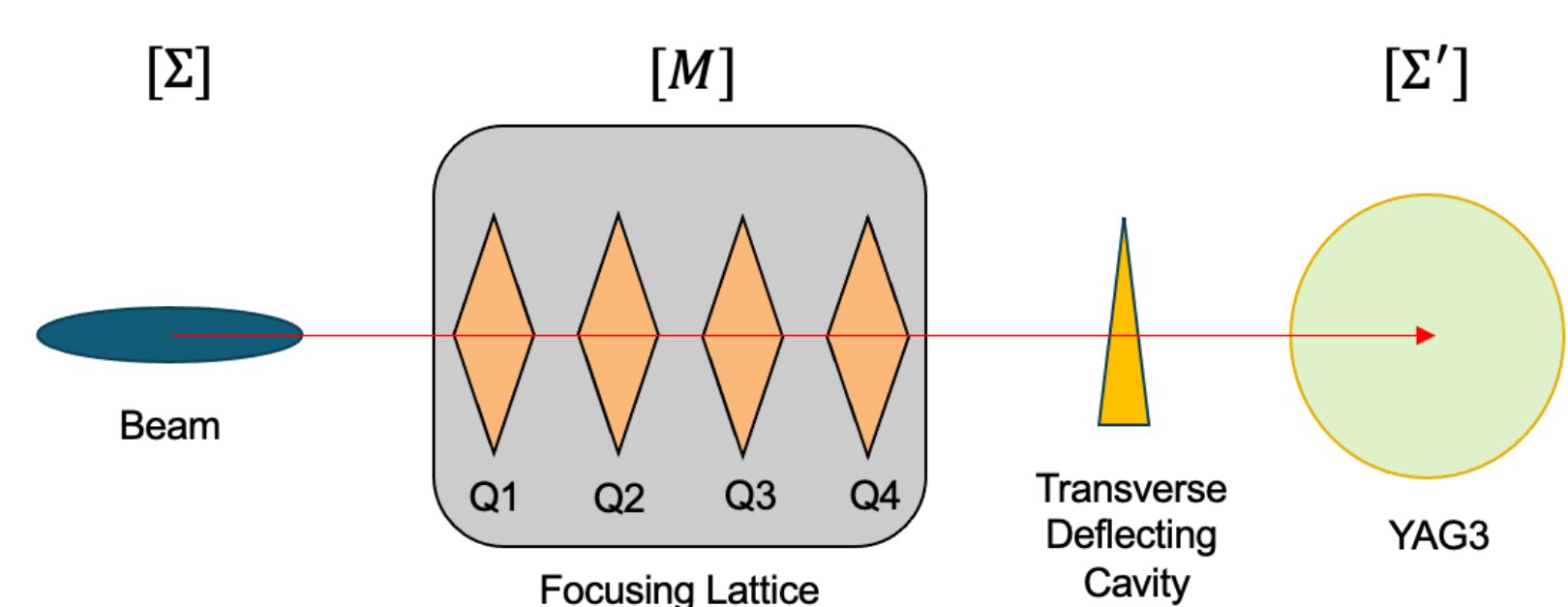
- Capable of evaluate electron beam quality with time resolution of 1 ps
- Fully characterize transverse and longitudinal beam profiles



- A **transverse deflecting cavity** (TDC) provides a time dependent transverse kick to the beam
- After TDC, the beam's longitudinal profile converts to Y direction, which is measurable on YAG screen



Emittance Measurement in Diagnostic Line



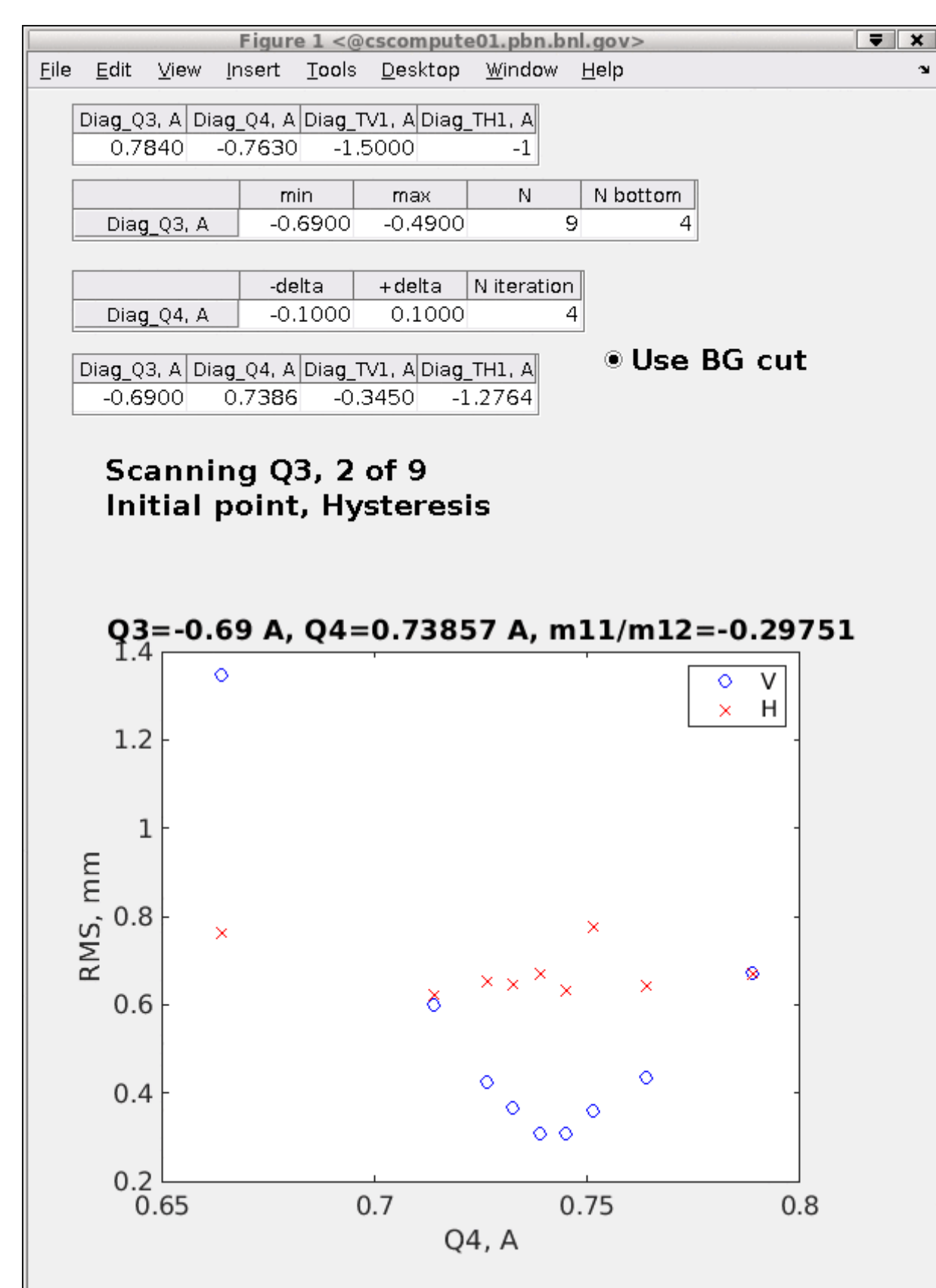
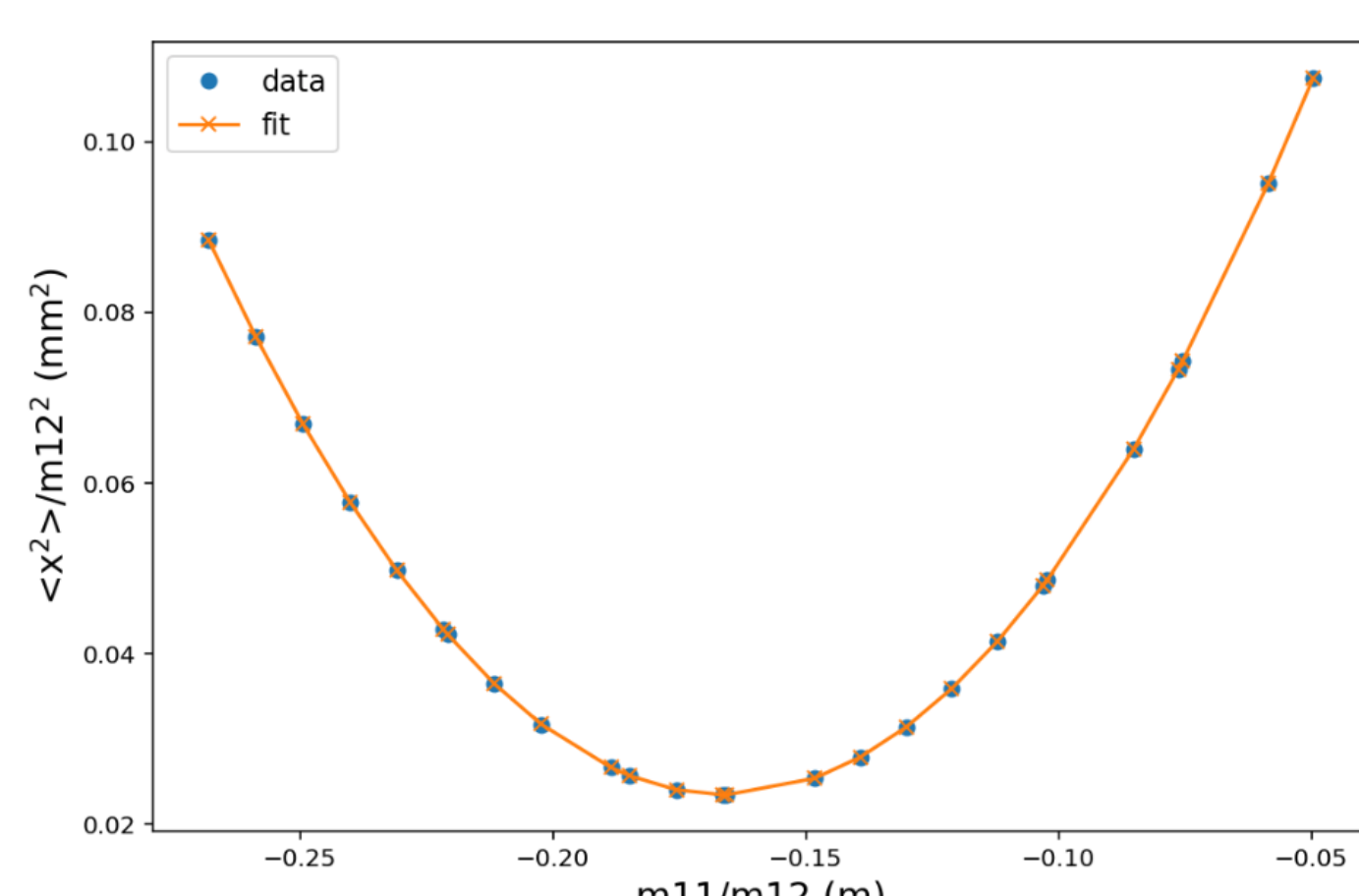
- Use **Q3** and **Q4** for quadrupole scan
- For each Q3 value, find Q4 value for best vertical focusing at **YAG3**
- Turn on **deflecting cavity**, convert longitudinal beam info to Y direction
- Slice beam vertically for slice emittance
- **Old routine:**
 - Scan 13 Q3 settings
 - For each Q3, scan 9 Q4 settings
 - > 1 hour for entire scan

Use **quadrupole scan** to measure emittance:

$$\begin{aligned} \therefore [\Sigma'] &= [M][\Sigma][M]^T \\ \therefore \sigma'_{11} &= m_{11}^2 \sigma_{11} + m_{11} m_{12} 2\sigma_{12} + m_{12}^2 \sigma_{22} \\ \text{Define } v &= \frac{m_{11}}{m_{12}}, \quad \sigma'_v = \frac{\sigma'_{11}}{m_{12}^2} \\ \sigma'_v(v) &= \sigma_{11} v^2 + 2\sigma_{12} v + \sigma_{22} \end{aligned}$$

Use parabola fit parameters to get emittance:

$$\varepsilon = \sqrt{\sigma_{11}\sigma_{22} - \sigma_{12}^2}$$



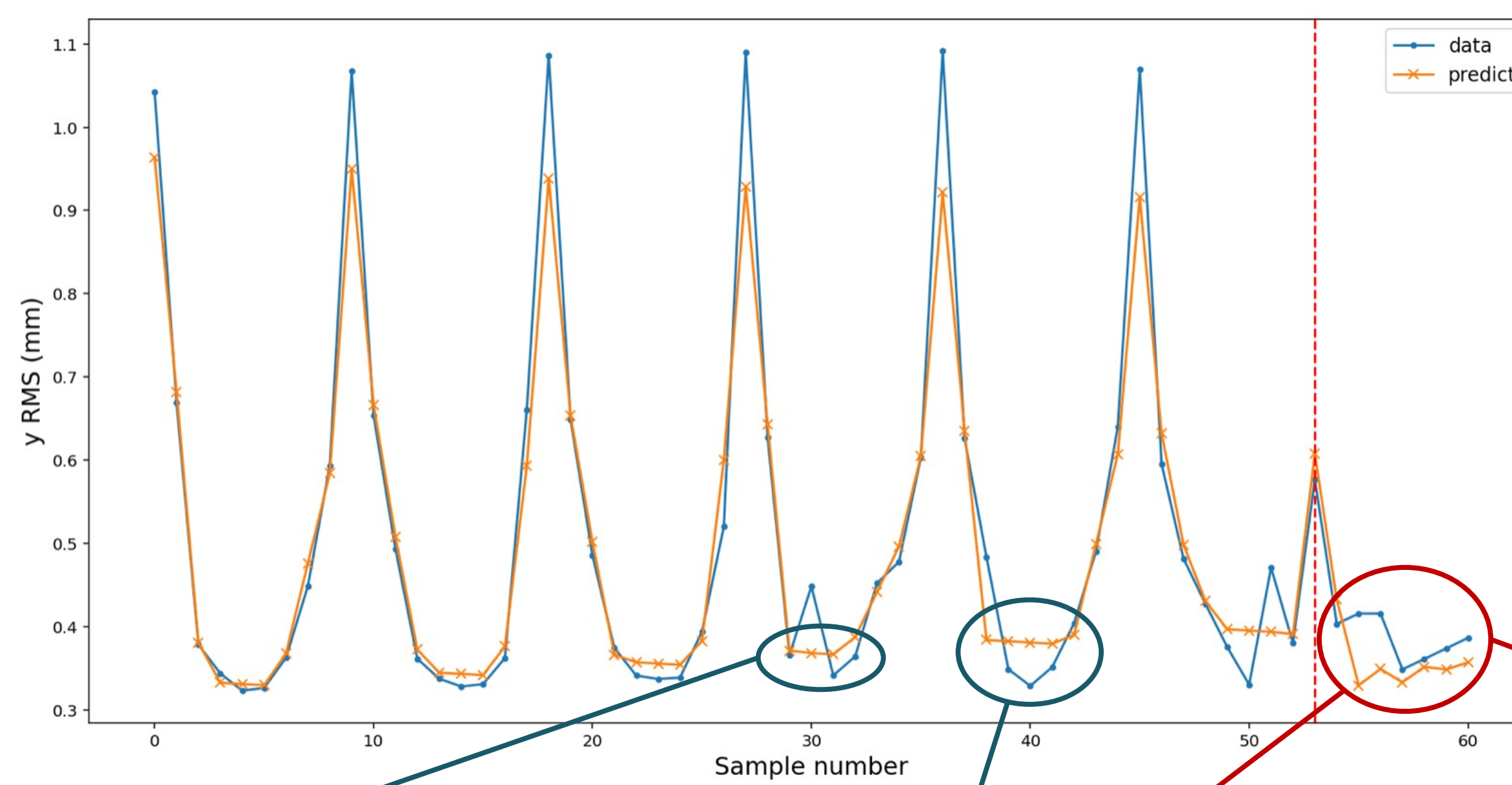
New Routine with Neural Network (NN):

- Scan 6 Q3 settings, save data
- Train NN model with saved data
- NN predicts best Q4 settings for remaining 7 Q3 settings
- Load predicted settings to beamline

Cut Scan Time by **50%**

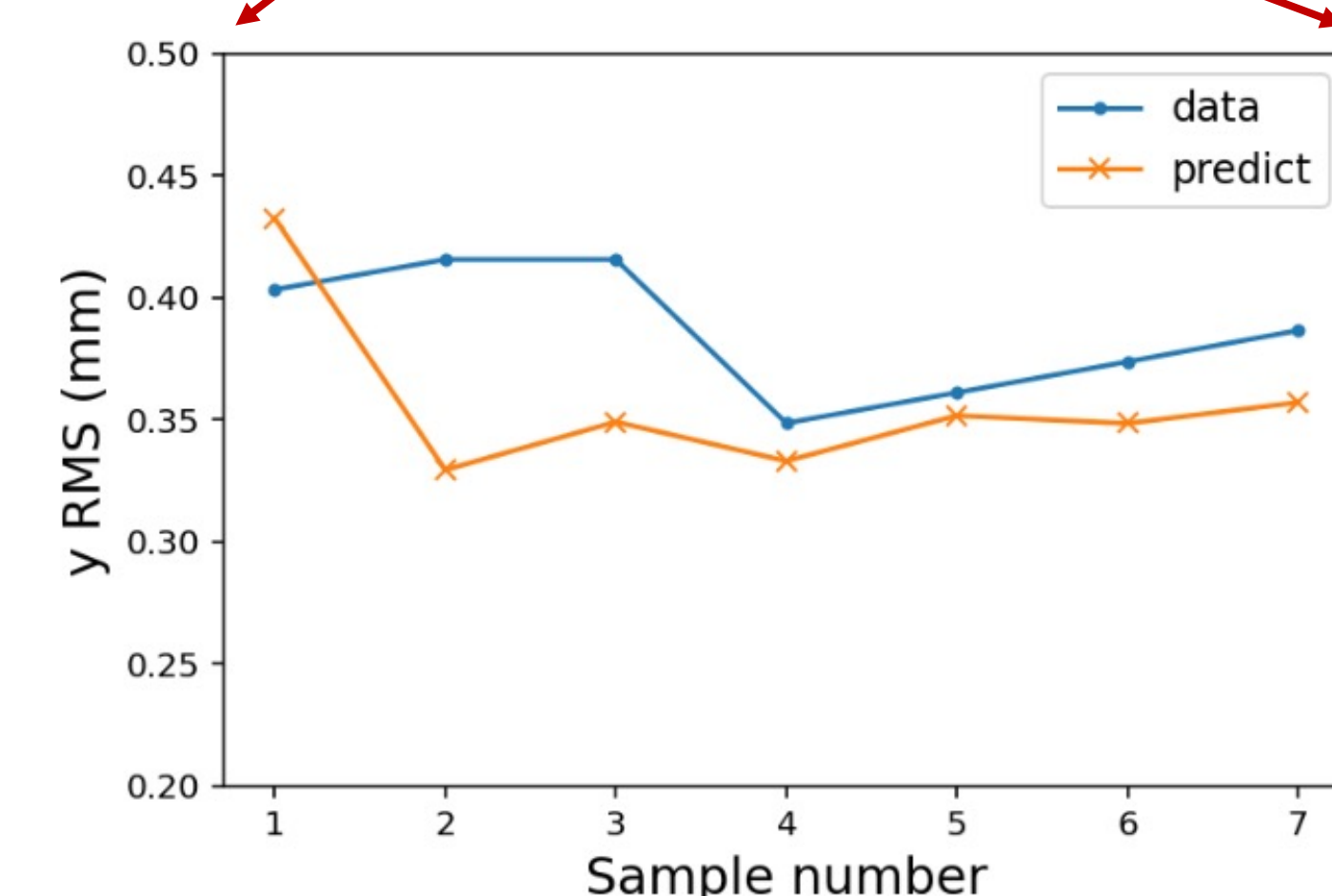
Results: test new routine on CeC system

First 6 rounds: 54 saved data points with old script



Remaining 7 rounds: 7 data points using Q3-Q4 settings predicted by NN model

Need to fix: trouble getting the small Y RMS region features



- **Satisfactory preliminary results:**
 - Obtained 7 Y RMS values all around 0.3 – 0.4 mm range
 - Future work: incorporate new routine into control system